

L Number	Hits	Search Text	DB	Time stamp
1	17	isolat\$3 near photodiode.ti.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 09:27
8	254819	cmos near image sensor.ti.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 09:50
9	228	cmos near image near sensor.ti.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 09:50
10	104	(cmos near image near sensor.ti.) and photodiode	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 09:51

L Number	Hits	Search Text	DB	Time stamp
1	17	isolat\$3 near photodiode.ti.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 12:44
8	254819	cmos near image sensor.ti.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 09:50
9	228	cmos near image near sensor.ti.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 09:50
10	104	(cmos near image near sensor.ti.) and photodiode	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 09:51
25	83	isolat\$3 near photodiode.ab.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 11:15
26	83	(isolat\$3 near photodiode.ab.) and photodiode	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 12:02
29	1120232	sensor	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 12:44
30	4033	Mos and photodiode	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 12:45
31	2176	sensor and (Mos and photodiode)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 12:45
32	75765	concentration and conductivity	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 12:46
33	232	((sensor and (Mos and photodiode)) and (concentration and conductivity))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 12:47
34	196	((sensor and (Mos and photodiode)) and (concentration and conductivity)) and @ad<20010119	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/10/01 12:47